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PATENT
Attorney Docket No.: SSI-02001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Maximilian A. Biberger *et al.*

Serial No.: 09/841,800-

Filed: April 24, 2001 -

For: **METHOD OF DEPOSITING
METAL FILM AND METAL
DEPOSITION CLUSTER TOOL
INCLUDING SUPERCRITICAL
DRYING/CLEANING MODULE**

) Group Art Unit: 2812

) Examiner:

) **TRANSMITTAL LETTER**

) 260 Sheridan Avenue, Suite 420
) Palo Alto, California 94306
) (650)833-0160

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Enclosed please find a Supplemental Information Disclosure Statement, a Certification pursuant to 37 C.F.R. § 1.97(e) for the Information Disclosure Statement, and Form PTO-1449, including copies of the references contained thereon, for filing in the U.S. Patent and Trademark Office.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. 08-1275. **An originally executed duplicate of this transmittal is enclosed for this purpose.**

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 12-21-01

By: Thomas B. Haverstock
Thomas B. Haverstock
Reg. No.: 32,571

Attorneys for Applicants

CERTIFICATE OF MAILING (37 CFR § 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Assistant Commissioner for Patents, Washington D.C. 20231

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HAVERSTOCK & OWENS LLP

Date: 12-24-01 By: Juan D. Rancor

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Group Art Unit: 2812

Examiner:

SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT

260 Sheridan Avenue, Suite 420
Palo Alto, California 94306
(650)833-0160

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

Applicant has become aware of the following printed publications which may be material to the examination of this application:

- German Publication No. DE 198 60 084 A1;
- European Publication No. EP 0 822 583 A2;
- European Publication No. EP 0 829 312 A2; and
- Japanese Abstract No. JP 2-209729.

CERTIFICATE OF MAILING (37 CFR § 1.8(a))

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HAVERSTOCK & OWENS LLP.

Date: 12-24-01 By: Juan D. Rios

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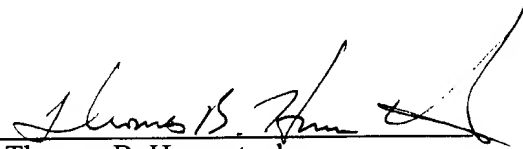


Attorney Docket No.: PATENT
SSI-02001

This Supplemental Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 12-21-01

By: 
Thomas B. Haverstock
Reg. No.: 32,571

Attorneys for Applicants



Attorney Docket No.: PATENT
SSI-02001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: 2812
Maximilian A. Biberger *et al.*) Examiner:
Serial No.: 09/841,800)
Filed: April 24, 2001) **CERTIFICATION FOR**
For: **METHOD OF DEPOSITING**) **SUPPLEMENTAL INFORMATION**
METAL FILM AND METAL) **DISCLOSURE STATEMENT**
DEPOSITION CLUSTER TOOL) **UNDER 37 CFR § 1.97(e)**
INCLUDING SUPERCRITICAL)
DRYING/CLEANING MODULE)
260 Sheridan Avenue, Suite 420
Palo Alto, California 94306
(650) 833-0160

Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

This certification is being made for the Supplemental Information Disclosure Statement accompanying this certification.

Certification

I hereby certify that the attached four (4) references contained in this information disclosure statement were cited within an International Search Report (ISR) mailed on November 27, 2001. **Accordingly, the references contained in the information disclosure statement were cited in a communication from a foreign patent office in a counterpart application not more than three months prior to the filing of the statement. 37 C.F.R. 1.97(e)(1).**

CERTIFICATE OF MAILING (37 CFR § 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Assistant Commissioner for Patents, Washington D.C. 20231

HAVERSTOCK & OWENS LLP.

Date: 12-24-01 By: Tuan D. Korman

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Attorney Docket No.: PATENT
SSI-02001

Identification of Person Making Certification

The person making this certification is the attorney who signs below on the basis of the information in the attorney's file.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 12-21-01

By: Thomas B. Haverstock

Thomas B. Haverstock
Reg. No.: 32,571

Attorneys for Applicants

ORM PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office		Attorney Docket No.: SSI-02001		Serial No.: 09/841,800	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets If Necessary)				Applicant: Maximilian A. Biberger <i>et al.</i>			
(37 CFR § 1.98(b))				Filing Date: April 24, 2001		Group Art Unit: 2812	
FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS							
	Document Number	Publication Date	Country / Patent Office	Class	Subclass	Translation	
						Yes	No
	DE 198 60 084 A1	07/06/00	Germany	H 01 L	21/3213		X
AB	EP 0 822 583 A2	02/04/98	EP	H01L	21/306		X
AC	EP 0 829 312 A2	03/18/98	EP	B 08 B	3/08		X
AD	JP 2-209729	8/21/90	JP	H 01 L	21/302		X
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Examiner:				Date Considered:			
EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

